

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Jarmo Ilmari Maula, et al.

Application No. 10/609,136

Filed: June 26, 2003

For: **DIAPHRAGM VALVE FOR HIGH-TEMPERATURE PRECURSOR SUPPLY IN ATOMIC LAYER DEPOSITION**

Group Art Unit: 3753

Examiner: Kevin L. Lee

Date: March 31, 2005

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to:

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TO THE COMMISSIONER FOR PATENTS:

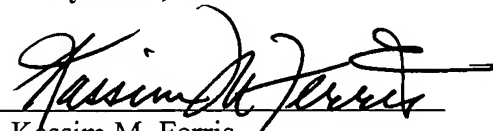
Enclosed for filing in the above-referenced application are the following:

- ☒ Part B – Fee(s) Transmittal
- ☒ Second Supplemental Information Disclosure Statement
- ☒ Form PTO-1449 Equivalent
- ☒ Check for \$1,210.00
- ☒ Return receipt postcard

The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455.

Respectfully submitted,

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